

Application/Control No.	Applicant(s)/Patent under Reexamination	
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Examiner	Art Unit	
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SEARCHED				
Class	Subclass	Date	Examiner	
715	200	3/21/2011	CLH	
	249	3/21/2011	CLH	

INTERFERENCE SEARCHED				
Subclass	Date	Examiner		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
East	3/21/2011	CLH
Google Scholar	3/21/2011	CLH